

CORRECTION

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Correction: Vacancy induced microstrain in high-entropy alloy film for sustainable hydrogen production under universal pH conditions

Yiyuan Yang,^a Zhe Jia,^{*a} Qianqian Wang,^a Yujing Liu,^b Ligang Sun,^{*c} Bo Sun,^a Juan Kuang,^a Shoujun Dai,^d Jianguo He,^d Sida Liu,^e Lunbo Duan,^f Hongjian Tang,^f Lai-Chang Zhang,^g Jamie J. Kruzic,^h Jian Luⁱ and Baolong Shen^{*a}

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Correction for 'Vacancy induced microstrain in high-entropy alloy film for sustainable hydrogen production under universal pH conditions' by Yiyuan Yang et al., *Energy Environ. Sci.*, 2024, <https://doi.org/10.1039/d4ee01139b>.

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There was an error in the peak labels for Fig. 1c. Fig. 1 should appear as follows.

The Royal Society of Chemistry apologises for these errors and any consequent inconvenience to authors and readers.

^a School of Materials Science and Engineering, Jiangsu Key Laboratory for Advanced Metallic Materials, Southeast University, Nanjing, 211189, China. E-mail: zhejia@seu.edu.cn, blshen@seu.edu.cn

^b Institute of Metals, College of Materials Science and Engineering, Changsha University of Science & Technology, Changsha, 410114, China

^c School of Science, Harbin Institute of Technology, Shenzhen, 518055, China. E-mail: sunligang@hit.edu.cn

^d Key Laboratory of Computational Optical Imaging Technology, Aerospace Information Research Institute, Chinese Academy of Sciences, Beijing, 100094, China

^e Laboratory for Multiscale Mechanics and Medical Science, SV LAB, School of Aerospace Xi'an Jiaotong University, Xi'an, 710049, China

^f Key Laboratory of Energy Thermal Conversion and Control, Ministry of Education, School of Energy and Environment, Southeast University, Nanjing, 210096, China

^g Centre for Advanced Materials and Manufacturing, School of Engineering, Edith Cowan University, 270 Joondalup Drive, Joondalup, Perth, WA 6027, Australia

^h School of Mechanical and Manufacturing Engineering, University of New South Wales (UNSW Sydney), Sydney, NSW 2052, Australia

ⁱ Hong Kong Branch of National Precious Metals Material Engineering Research Center and Department of Mechanical Engineering, City University of Hong Kong, Hong Kong SAR, China



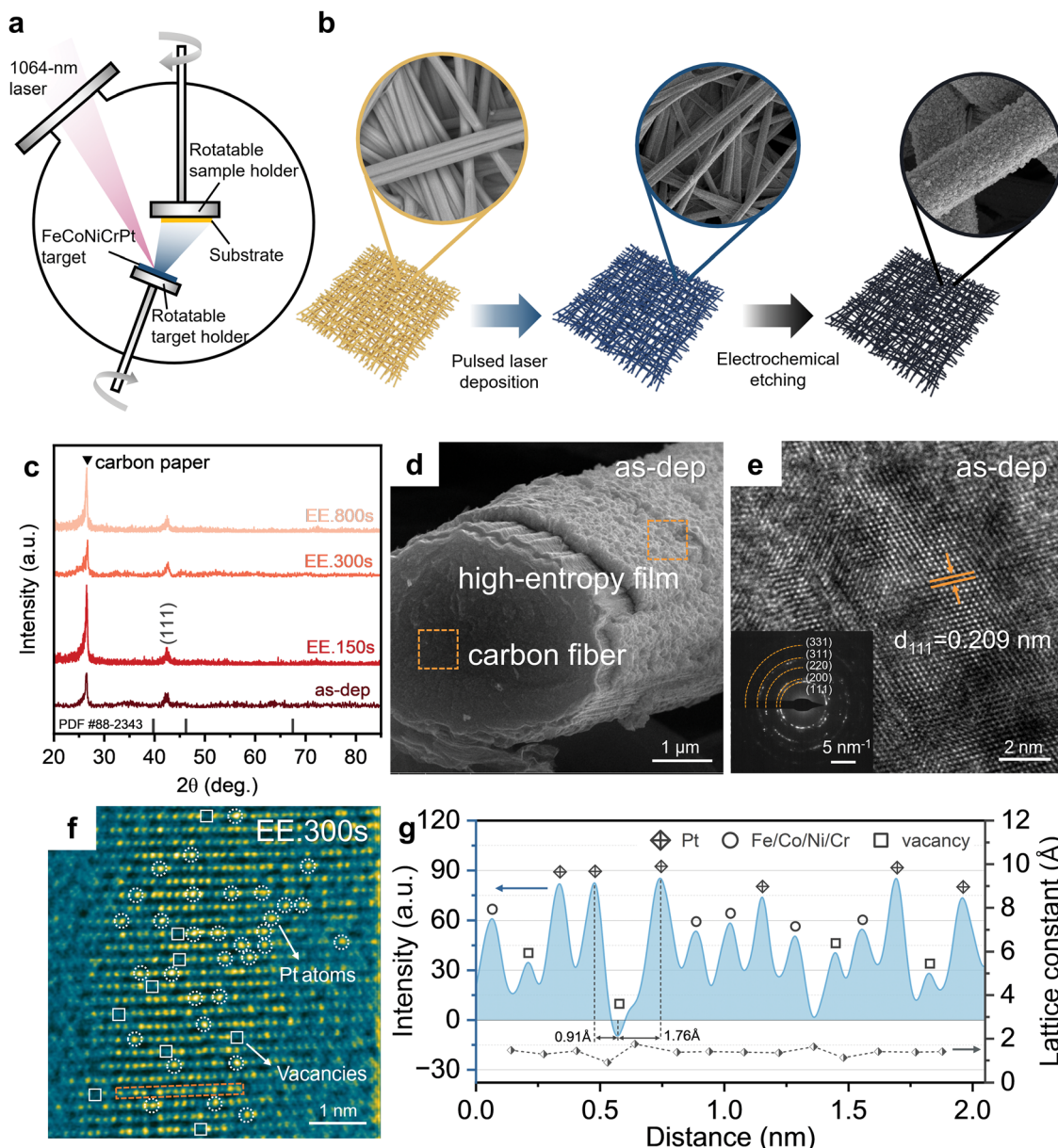


Fig. 1 Preparation and characterization of FeCoNiCrPt HEA films. Schematic diagrams of the (a) PLD and (b) electrochemical etching processes of the HEA film on a carbon paper substrate. (c) GIXRD profile of the HEA films before and after electrochemical etching. (d) SEM image and (e) HRTEM image with SAED pattern (inset) of the as-dep HEA film. (f) HRTEM image of the EE.300s HEA film, where Pt atoms are marked by white dotted circles, and vacancies are marked by white squares. (g) Integrated pixel intensity profile for the EE.300s HEA film derived from the dotted orange box in (f), where peaks and valleys represent the atomic column and gap positions, respectively.

